



JPW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Katsutoshi Izumi et al

Group Art Unit: 2813

Serial No.: 10/802,806

Examiner: Heather Ann Doty

Filed: March 18, 2004

P.T.O. Confirmation No.: 5100

For: MANUFACTURING METHOD FOR BURIED INSULATING LAYER-TYPE
SEMICONDUCTOR SILICON CARBIDE SUBSTRATE

INFORMATION DISCLOSURE STATEMENT
PURSUANT TO 37 CFR 1.97(c)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

February 7, 2006

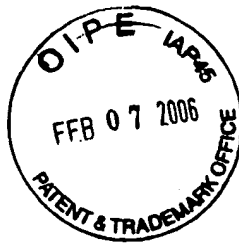
Sir:

The attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached Form PTO-1449. One copy of each of these documents is attached.

Document AA-AC and AE-AG was cited in an European Search Report dated December 16, 2005. A copy of the Search Report is also attached.

This Information Disclosure Statement is being submitted after issuance of a first official action on the merits and expiration of the three month period following the filing date or the entry in the national stage for the above-captioned application, but prior to issuance of either a final official action, a Notice of Allowance, or an action that otherwise closes prosecution in the application.

The undersigned hereby certifies that each item of information contained in this statement was first cited in any communication from a foreign patent office in a counterpart



Serial No. 10/802,806

foreign application not more than three months prior to the filing of this statement.

The above information is presented so that the Patent and Trademark Office can, in the first instance, determine any materiality thereof to the claimed invention. See 37 CFR 1.104(a) concerning the PTO duty to consider and use any such information. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the documents cited in the attached Form PTO-1449 be made of record therein and appear on the first page of any patent to issue therefrom.

The Commissioner is authorized to charge our Deposit Account No. 01-2340 for any fee which is deemed by the Patent and Trademark Office to be required to effect consideration of this statement.

Respectfully submitted,

ARMSTRONG, KRATZ, QUINTOS, HANSON & BROOKS, LLP

Donald W. Hanson
Attorney for Applicants
Reg. No. 27,133

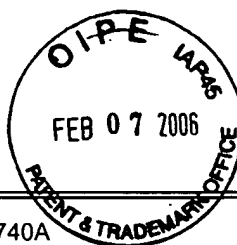
Atty. Docket No. 021740A
Suite 1000, 1725 K Street, N.W.
Washington, D.C. 20006
(202) 659-2930
DWH/nk



23850

PATENT TRADEMARK OFFICE

Enclosures: PTO1449; Search Report; 6 references



INFORMATION DISCLOSURE CITATION PTO-1449	Atty. Docket No. 021740A	Serial No. 10/802,806
	Applicant(s): Katsutoshi Izumi et al	Confirmation No. 5100
	Filing Date: 3/18/04	Group Art Unit: 2813

U.S. PATENT DOCUMENTS

Examiner Initial		Document No.	Name	Date	Class	Sub- class	Filing Date (If appropriate)
_____	AA	5,880,491	Soref et al	3/9/99	257	190	
_____	AB	5,759,908	Steckl et al	6/2/98	438	479	
_____	AC	5,415,126	Loboda et al	5/16/95	117	88	
_____	AD						

FOREIGN PATENT DOCUMENTS

		Document No.	Date	Country	Translation (Yes or No)
_____	AE	1265274	12/11/02	EP	
_____	AF	06191997	7/12/94	JP	yes, abstract and machine translation
_____	AG	0454456	10/30/91	EP	
_____	AH				
_____	AI				
_____	AJ				
_____	AK				
_____	AL				

OTHER DOCUMENTS

_____	AM	European Search Report dated December 16, 2005
_____	AN	

Examiner	Date Considered
----------	-----------------